

Electronic Acknowledgement Receipt

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Application Number:	10549334
International Application Number:	
Confirmation Number:	6690
Title of Invention:	Crystallization apparatus and method of amophous silicon
First Named Inventor/Applicant Name:	Su-Gyeong Lee
Customer Number:	22150
Filer:	Frank Chau/Susan Ramunto
Filer Authorized By:	Frank Chau
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Application Type:	U.S. National Stage under 35 USC 371

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Request for Corrected Filing Receipt	8071-103ReqeustCorrectedF R.pdf	1023762	no	14

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If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.		
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If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.		